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## -- CROSS REFERENCE TO RELATED APPLICATION

This application is a continuation of U.S. Patent Application Serial No. 08/497,382 filed June 29, 1995, now allowed, which is incorporated by reference herein in its entirety.--;

Page 2, line 2, kindly change "is produced found in" to --is--;

Page 3, line 16, delete "or water."

Page 6, line 9, kindly change "16" to --18--

Page 7, line14, kindly change "wafers" to --wafer-

Page 7, line 30, kindly change "focusses" to --focuses--;

Page 8, line 2, kindly change "114" to --1 16--;

Page 8, line 3, kindly change "114" to --116--

Page 8, line 11, kindly change "focusses" to --focuses--;

Page 8, line 11, kindly change "114" to --116--;

Page 8, line 14, kindly change "114" to --116--,

Page 8, line 17, kindly change "10 - 14" to --10 - 13--.

## IN THE CLAIMS

Cancel Claims 1-16 and substitute new Claims 1-1/5 as set forth below.

11/1.1

A semiconductor article processing apparatus comprising:

a processing unit having a working area for processing a top layer of an article; an optical measurement station adjacent to said processing unit; and

a transporter for transporting said article between said processing unit and said optical measurement station;

said optical measurement station located outside said working area and comprising:

an optical measuring unit for measuring a desired parameter of said top layer and;

a holding unit for receiving and holding said article in a stationary measurement position;

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